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571-203-2790

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ATTORNEY DOCKET NO.: 04329.3083
CUSTOMER NUMBER: 22,852

Mail Stop Patent Application
Assistant Commissioner for Patents
Washington, D.C. 20231

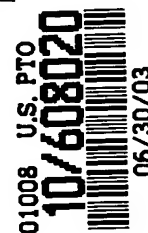
New U.S. Patent Application

Title: METHOD OF PURGING SEMICONDUCTOR MANUFACTURING
APPARATUS AND METHOD OF MANUFACTURING
SEMICONDUCTOR DEVICE

being a Continuation of PCT International

Application No. PCT/JP02/08742 filed August 29, 2002

Inventor: Ichiro MIZUSHIMA



Dear Sirs:

We enclose the following papers for filing in the United States Patent and Trademark Office under 35 U.S.C. 111(a) as a **Continuation** application of PCT International Application No. PCT/JP02/08742 filed August 29, 2002 which claimed priority of **Japanese** Patent Application No. 2001-262295, filed August 30, 2001.

1. Application 29 pages, including 4 independent claims and 32 claims total.
3. Drawings 1 sheet of containing 2 figures.
4. Declaration and Power of Attorney
5. Recordation Form Cover Sheet and Assignment to Kabushiki Kaisha Toshiba
6. Certified copy of Japanese Patent Application No. 2001-262295 filed August 30, 2001.
7. Information Disclosure Statement and Information Disclosure Citation, PTO 1449 with document attached.
8. The filing fee is calculated as follows:

Basic Application Filing Fee					\$750	\$750.00
	Number of Claims		Basic	Extra Claims		
Total Claims	32	-	20	12	x \$18	\$216.00
Independent Claims	4	-	3	1	x \$84	\$84.00
<input checked="" type="checkbox"/> Presentation of Multiple Dep. Claim(s)					+\$280	\$280.00
Subtotal						\$ 1330.00
Reduction by ½ if small entity						-
TOTAL APPLICATION FILING FEE						\$ 1330.00

9. A check for \$1370.00 is enclosed. The fee includes:

\$750.00 filing fee;

\$580.00 additional claims fee; and

\$40.00 Assignment recordation fee.

10. Copy of Cover page of WIPO Publication No. WO 03/019634A1

Applicants claim the right to priority based on Japanese Patent Application No. 2001-262295 filed August 30, 2001.

Please address all correspondence with respect to this application to:

Finnegan, Henderson, Farabow,
Garrett & Dunner, L.L.P.
1300 I Street, N.W.
Washington, D.C. 20005-3315



Please accord this application a serial number and filing date and record and return the Assignment to the undersigned.

The Commissioner is hereby authorized to charge any additional filing fees due and any other fees due under 37 C.F.R. § 1.16 or § 1.17 during the pendency of this

application to our Deposit Account No. 06-0916.

Sincerely,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.


By: 

Richard V. Burgujian

Reg. No. 31,744

RVB/dvz
Enclosures

ERNEST F. CHAPMAN
Reg. No. 25,961